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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: LAMARRE, Philip A.

Group Art Unit: 1756

Serial No.

10/710,023

Examiner: BARRECA, Nicole M

· Filed:

06/14/2004

Dkt No: 20030146-US

LITHOGRAPHIC SEMICONDUCTOR MANUFACTURING USING A **MULTI-LAYERED PROCESS** 

To:

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42716

Commissioner for Patents

PO Box 1450

Alexandria, VA 22313-1450

CERTIFICATE OF FACSIMILE 37 CFR 1.8: I certify that this correspondence is being faxed to: Examiner Barreca , at FAX #: <u>571-273-8300</u>, TEL #: <u>571-272-1379</u> on the below date.

Date: Occember

Debra A. Stengel or [ ] Scott J. Asmus, Rog. No. 42,269

Commissioner:

## AFTER FINAL OFFICE ACTION RESPONSE AMENDMENT

## INTRODUCTORY COMMENTS

12/2/102 mm In response to the Office's Final Office Action dated 10/18/2005, the Applicant has timely enclosed herein: 9 pages Office Action Response. Please amend the above-identified application as follows:

> Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.

DEPOSIT ACCOUNT 190130 AUTHORIZATION - The Office is hereby authorized to charge the required fee, and any deficiency or credit any overpayment in the fees to the above deposit account, owned by BAE SYSTEMS Information and Electronic Systems Integration Inc. an authorized signator for which is Kevin M. Perkins, V.P. & Company Counsel, and for whom the undersigned are authorized agents.

Page 1 of 9